



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#14/C 6B Patent
42534-3100 8/21/03

In re Application of:

Yoichi Kato

Application No.: 09/591,565

Filed: June 9, 2000

For: NEGATIVE ION EMITTING
METHOD AND APPARATUS
THEREFOR

Patent Examiner: David A. Vanore

Group Art Unit: 2881

August 4, 2003

Irvine, California 92614-7230

AMENDMENT

Commissioner for Patents
PO Box 1450
Arlington, VA 22313-1450

Dear Sir:

In response to the Office Action mailed February 4, 2003, Applicant submits the following claims and arguments. Please amend the above-identified application for patent as follows.

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